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Applicant : Hisashi Ohtani, et al.

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Title

: METHOD OF FABRICATING SEMICONDUCTOR DEVICES

Commissioner of Patents Washington, D.C. 20231

REQUEST FOR DRAWING CORRECTION

In FIG. 1D, please change the label 108 to read --104--. Entry is shown in red on the attached FIG. 1D and is respectfully requested. This change conforms the drawings to comport with the specification.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

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I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

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